

Supporting Information for

Formation of Superatom Monolayer Using Gas-Phase-Synthesized Ta@Si₁₆ Nanocluster Ions

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1. Effect of V_{tip} on the dot height measured by STM on dots/ C_{60} and dots/6T

In the main text, we discussed the geometry of Ta@Si₁₆ nanoclusters adsorbed on thin films of C₆₀ and 6T molecules using the heights of dots created by depositing Ta@Si₁₆ cations onto both molecular films, where each dot height was estimated as the difference in height of the STM tip between the tops of the dot and the molecules. Since the tip height difference between adsorbates and surfaces in STM images is generally affected by the difference in the electrical density of states (DOS) between them, there is a possibility that the heights of dots on molecular films fluctuate depending on the tip bias voltage (V_{tip}). Therefore, the effect of the value of V_{tip} on the dot height (h_d) should be investigated before discussing the geometry of Ta@Si₁₆ nanoclusters.

In the case of Ta@Si₁₆/C₆₀, the height difference between the Ta@Si₁₆ nanocluster and C₆₀ molecules in the filled-state imaging ($V_{\text{tip}} > 0$) would be observed to be higher than the original height difference, particularly, in the range of V_{tip} from ~ 0.5 V to ~ 2.2 V. This is because C₆₀ molecules exhibit a large energy gap in the filled state, as shown in Fig. 4f in the main text, whereas the Ta@Si₁₆ nanocluster shows a clear peak in the DOS at V_{tip} of ~ 1.0 V, as shown in the Fig. 4c, 4d, and 4e. In contrast, in the empty state ($V_{\text{tip}} < 0$), the difference in electronic structure between the Ta@Si₁₆ nanocluster and the C₆₀ molecule is clearly smaller than that in the filled state. Of course, since the electronic DOS in the empty state of the Ta@Si₁₆ nanocluster does not completely agree with that of C₆₀ molecules, there is a possibility that the height of dots on C₆₀ films fluctuates with the value of V_{tip} . However, our additional result indicates that this fluctuation is negligible, as follows. The black, blue, and red curves in Fig. S1b show STM height profiles taken at V_{tip} of -2.3 V, -2.0 V, and -1.7 V, respectively, which intersect the same three dots with h_d of ~ 0.7 nm, ~ 0.8 nm, and ~ 0.85 nm, as indicated by the dotted blue line in Fig. S1a. In these profiles, the heights of the three dots are independent of the value of V_{tip} , strongly indicating that the difference in the electronic DOS between the Ta@Si₁₆ nanocluster and the C₆₀ molecule has a negligible impact on the height difference between them in empty-state imaging. Therefore, it is concluded that the geometry of Ta@Si₁₆/C₆₀ can be safely discussed on the basis of the dot-height histograms shown in Fig. 1f and 1g in the main text.

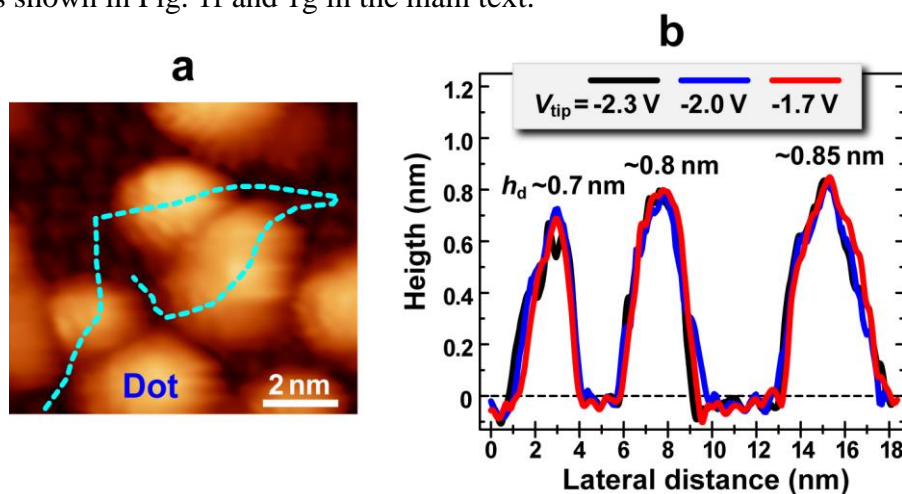


Fig. S1. (a) STM image of C₆₀/HOPG taken after depositing Ta@Si₁₆ cations. (b) Cross-sectional line profiles taken along the blue line in (a) at V_{tip} of -2.3 V (black), -2.0 V (blue), and -1.7 V (red).

Fig. S2a, S2b, and S2c show histograms of h_d measured on dots/6T from STM height profiles taken at V_{tip} of 1.7 V, -1.4 V, and -1.6 V, respectively. These results clearly indicate that the dot height distribution of dots/6T does not sensitively fluctuate with the value of V_{tip} , allowing us to conclude that the geometry of Ta@Si₁₆/6T can also be safely discussed on the basis of the histogram shown in Fig. 3c in the main text.

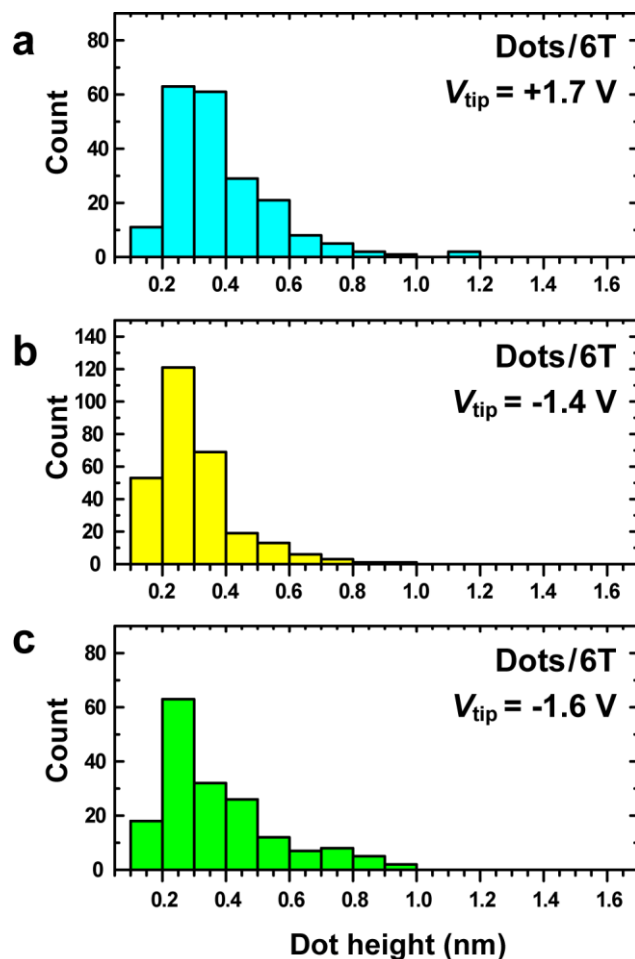


Fig. S2. (a-c) Histograms of dot heights measured on the dots/6T from STM height profiles taken at V_{tip} of +1.7 V, -1.4 V, and -1.6 V, respectively.

2. Deposition of Ta@Si₁₆ cations onto C₆₀-terminated HOPG with higher kinetic energy

We have investigated the effect of nanocluster fragmentation or deformation on dot formation in the deposition of Ta@Si₁₆ cations onto C₆₀-terminated surfaces. To intentionally induce fragmentation or deformation on surfaces, Ta@Si₁₆ cations were deposited onto a C₆₀-terminated HOPG surface with a kinetic energy (E_k) of ~1.25 eV/atom, which is ~20 times larger than that used to obtain the samples shown in Fig. 1a–1d, 1f, and 1g in the main text. As a result, dots with $h_d < 0.45$ nm were mainly created, as shown in Fig. S3a and S3b. The formation of dots with $h_d < 0.45$ nm was considered to come from the deformation and/or fragmentation of Ta@Si₁₆

nanoclusters on the surface, because such small values of h_d cannot be explained by the adsorption of Ta@Si₁₆ nanoclusters. In contrast, the small dots with $h_d < 0.45$ nm are minor products in the deposition of Ta@Si₁₆ cations with a smaller E_k of ~ 0.01 eV/atom, as shown in Fig. 1f and 1g, also suggesting that the fragmentation or deformation of Ta@Si₁₆ nanoclusters hardly occurs in the low-energy deposition of cations.

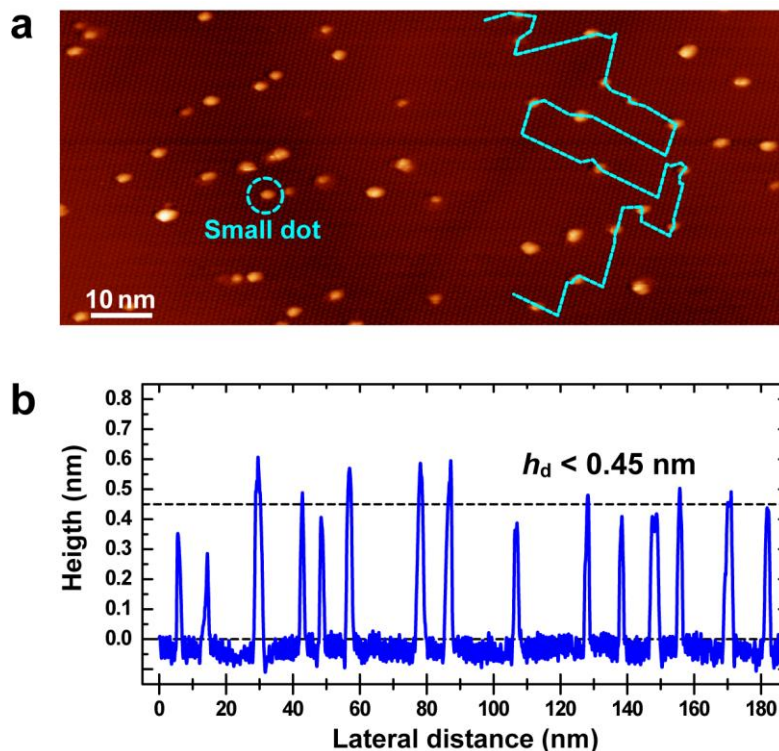


Fig. S3. (a) STM image of C₆₀/HOPG surface taken after depositing Ta@Si₁₆ cations with E_k of ~ 1.25 eV/atom. (b) Cross-sectional line profile taken along the blue line in (a).

3. Optimized structures and electronic properties of Ta@Si₁₆-C₆₀ complexes

To gain insights into the structural and electronic properties of Ta@Si₁₆ cations immobilized on C₆₀ monolayer films, geometrical optimizations of Ta@Si₁₆⁺⁰-C₆₀ complexes starting from several initial structures were performed with TURBOMOLE 6.4-6.5^{1,2} at the level of the Perdew-Burke-Ernzerhof functional³ using the resolution-of-identity approximation⁴ and the def-SV(P) basis set⁵ along with a scalar relativistic effective core potential for Ta.⁶ Geometric optimizations were continued until the vibrational frequency analysis showed no imaginary frequencies, along the largest of which when found the geometric structures are relaxed. Natural population analysis⁷ was used to investigate the charge distributions in the complexes.

Fig. S4 shows the optimized structures of Ta@Si₁₆-C₆₀ complexes with cationic (a–c) and neutral (d–f) states, where the neutral states were optimized starting from the corresponding cation structures after their optimization. Representative structural parameters, relative total energies (ΔE), HOMO–LUMO gaps (E_g), and natural charges of Ta@Si₁₆ nanoclusters ($Q_{\text{TaSi@16}}$) are summarized in Table S1. For all the optimized structures of the Ta@Si₁₆-C₆₀ complexes, the Ta@Si₁₆

nanoclusters possess a fullerene structure having almost D_{4d} symmetry, even when a Frank-Kasper (FK) structure having almost T_d symmetry was given as the initial structure of the Ta@Si₁₆ nanoclusters (Fig. S4c). Some structures starting from $^{FK}\text{Ta@Si}_{16}\text{-C}_{60}$ (not shown here) result in separate configurations, i.e., covalent interconnection between Ta@Si₁₆ nanoclusters and C₆₀ molecules is not realized owing to the large bond length among nearest-neighbor Si and C atoms. This result suggests that individual $^{FK}\text{Ta@Si}_{16}$ cations are too stable to chemically bond with C₆₀ molecules. The formation of the $^{FK}\text{Ta@Si}_{16}\text{-C}_{60}$ complex via the increased intercluster distance may be one of the causes of the variation in height of the Ta@Si₁₆ nanoclusters on C₆₀ films reported in the text, although a detailed theoretical verification considering the van der Waals interaction between Ta@Si₁₆ nanoclusters and C₆₀ molecules is required, which is beyond the scope of the present study.

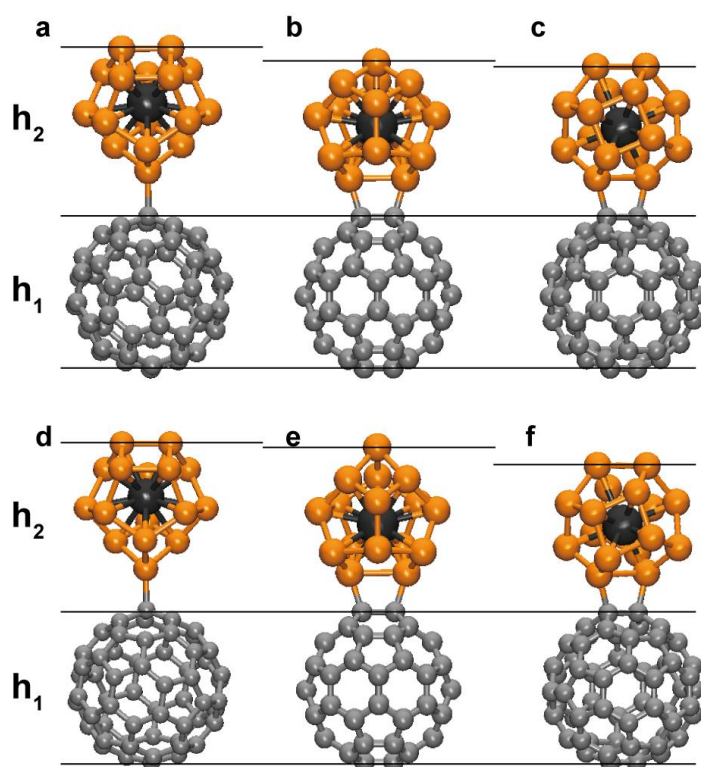


Fig. S4 Optimized structures of (a–c) $[\text{Ta@Si}_{16}\text{-C}_{60}]^+$ and (d–f) $\text{Ta@Si}_{16}\text{-C}_{60}$, where orange, black, and gray spheres represent Si, Ta, and C atoms, respectively.

To discuss the apparent height of Ta@Si₁₆/C₆₀ in the STM observation, the distance between the centers of the topmost C and Si atoms in the C₆₀ molecules and Ta@Si₁₆ nanoclusters (h_2 in Fig. S4), respectively, is first estimated as the height of the Ta@Si₁₆ nanoclusters. The value of h_2 varies from 7.2 to 8.1 Å among the complexes in their neutral and cationic states, in reasonable agreement with the experimental height of Ta@Si₁₆ nanoclusters on C₆₀ films shown in the main text. Furthermore, considering the difference in the van der Waals radii between Si (2.1 Å) and C (1.7 Å) atoms, the heights shown in Fig. 2 in the text were estimated by adding this difference (0.4 Å) to each value of h_2 .

In addition, regarding the charge state of the Ta@Si₁₆ nanocluster in the neutral Ta@Si₁₆-C₆₀ complexes, it can be safely claimed that the Ta@Si₁₆ nanocluster tend to be positively charged as shown in Table S1, which supports the experimental results and the discussion in the text.

Table S1. Representative bond lengths and heights of C₆₀ molecules and Ta@Si₁₆ nanoclusters (h_1 and h_2 , respectively, see Fig. S4) in Å, relative total energies (ΔE), HOMO-LUMO gaps (E_g) in eV, and natural charges of Ta@Si₁₆ ($Q_{\text{TaSi}16}$) and C₆₀ ($Q_{\text{C}60}$) for complexes a–f in Fig. S4.

	Si-C	Ta-Si	Si-Si	C-C	h_1	h_2	ΔE	E_g	$Q_{\text{TaSi}16/\text{C}60}$
a	2.17	2.83-3.20	2.29-2.39	1.40-1.50	7.2	8.0	0.00	0.97	0.74/0.26
b	1.97	2.78-3.01	2.29-2.42	1.39-1.60	7.2	7.4	0.24	0.35	1.70/-0.70
c	1.96	2.74-3.17	2.30-2.65	1.39-1.60	7.2	7.2	0.27	0.40	1.71/-0.71
d	2.00	2.81-3.47	2.30-2.39	1.40-1.52	7.3	8.1	0.00	0.28	0.46/-0.46
e	1.98	2.78-3.70	2.29-2.83	1.39-1.59	7.2–7.3	8.0	0.12	0.52	0.89/-0.89
f	1.98-1.99	2.70-3.25	2.30-2.63	1.39-1.60	7.3	7.2	0.34	0.30	0.88/-0.88

References for Supporting Information

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